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Sheet 1 of 1

Substitute Form PTO-1449 (Modified)		Department of Commerce Patent and Trademark Office	Attorney's Docket No. 10559-587001	Application No. 10/081,992
Information Disclosure Statement by Applicant (Use several sheets if necessary)		Applicant Been-Yih Jin et al.		
		Filing Date February 21, 2002	Group Art Unit 2812	
(37 CFR §1.98(b))				

Foreign Patent Documents or Published Foreign Patent Applications							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation Yes No
AA							
AB							
AC							
AD							
AE							

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
RP	AF	Chau et al., International Electron Devices Meeting 2000, San Francisco, CA, December 10-13, 2000.
RP	AG	Ghani et al., Symposium on VLSI Technology Digest of Technical Papers, Honolulu, HI, June 13-15, 2000.
RP	AH	Hubbard et al., "Thermodynamic stability of binary oxides in contact with silicon" J. Mater. Res., Vol. 11, No. 11, Nov. 1996.

Examiner Signature <i>Ron Pompey</i>	Date Considered 2-05-05
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	